

Docket No.: 12088/019001  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Shinichi Kawasaki et al.

Application No.: 10/500,317

Confirmation No.: 9863

Filed: June 28, 2004

Art Unit: 1792

For: PLASMA FILM FORMING SYSTEM

Examiner: R. Zervigon

**SUBMISSION ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated December 17, 2007, please reconsider this application in view of the following.